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520.39649CX3

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: MASUDA et al

Serial No.: 10/810,598

Filed: March 29, 2004

For: Plasma Processing System And A Sample Processing Method

Art Unit: 1763

Examiner: R. Kackar

SUPPLEMENTAL RESPONSE

Mail Stop: Box AF Response (No Fee)
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

April 24, 2006

Sir:

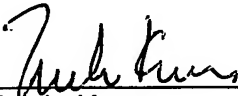
Submitted herewith is Appendix A which is referred to in the Amendment filed with the RCE on April 11, 2006 and which was inadvertently not attached thereto.

Consideration of the amendment together with Appendix A is requested.

To the extent necessary, applicants petition for an extension of time under 37 CFR 1.136. Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Case: 520.39649CX3), and please credit any excess fees to such deposit account.

Respectfully submitted,

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